IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

17/2/,

PECEIVED TO 18 2003

Applicant:

Sujit Sharan

Title:

METHODS OF FORMING COATINGS ON GAS-DISPERSION FIXTURES IN CHEMICAL-

VAPOR-DEPOSITION SYSTEMS

Docke: No.:

303.629US1

Filed:

August 29, 2001

Examiner:

Timothy Meeks

Serial No.: 09 942114

Due Date: August 12, 2003

Group Art Unit: 1762

Commissioner for Patents

P.O.Box 1450

Alexandria, VA 22313-1450



We are transmitting herewith the following attached items (as indicated with an "X")

A return postcard. \overline{X}

An Amendment and Response (14 Pages).

A check in the amount of \$420.00 to cover the fee for additional claims as calculated below.

If the additional fee is required due to changes to the claims, the fee has been calculated as follows:

		CI	AIMS AS AMENDEL			
	(1) Claims Remaining After Amendment		(2) Highest Number Previously Paid For	(3) Present Extra	Rate	Fee
TOTAL CLAIMS	39		39	0	18.00 =	\$0.00
INDEPENDENT CLAIMS	17		12	5	x 84.00 =	\$420.00
[]MULTIPLE DEPENDENT CLAIMS PRESENTED						\$0.00
TOTAL						\$420.00

Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A. P.O. Box 2938, Minneapolis, MN 55402 (612-373-6900)

Atty: Eduardo E. Drake

CFRTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner for Patents, P.O.Box 1450. Alexandria, VA 22313-1450, on this 12 day of August, 2003

Tina Kahout

Signature

Name

Customer Number 21186

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A. (GENERAL)

P.O. Box 2938, Minneapolis, MN 55402 (612-373-6900)

S/N 09/942114

<u>PATENT</u>

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CHEMICAL-VAPOR-DEPOSITION SYSTEMS

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Commissioner for Patents P.O.Box 1450 Alexandria, VA 22313-1450

ARCENTED AND Applicant has reviewed the Office Action mailed on May 12, 2003. Please amend the above-identified patent application as follows.

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